

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

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Application No.: Not Yet Assigned

**PATENT**

Filing Date: Herewith

Attorney Docket No. 101453-00067 SP101

Inventor(s): Venkat SELVAMANICKAM et al.

Group Art Unit: Not Yet Assigned

Examiner Name: Not Yet Assigned

Customer No.: 27160

Title: APPARATUS FOR AND METHOD OF  
CONTINUOUSHTS TAPE BUFFER  
LAYER DEPOSITION USING LARGE  
SCALE ION BEAM ASSISTED  
DEPOSITION

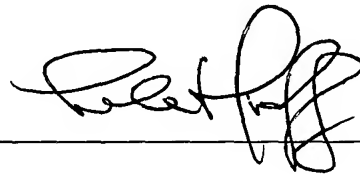
Mail Stop \_\_\_\_\_  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST TO MAKE SPECIAL**

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By: \_\_\_\_\_



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